



Docket No.: 050389-0052

**PATENT**

**Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Chihiro KAWAI, et al.

Application No.: 10/500,975

Customer No.: 20277

Filed: July 08, 2004

Confirmation No.: 3373

Group Art Unit: 2811

Examiner: Andrew O. Arena

Title: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of April 1, 2008, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 16 of this paper.